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## **BIB DATA SHEET**

10/549,938	CONFIRMATION NO. 7521									
10/549,938										
APPLICANTS Takashi Ozaki, Toyama, JAPAN; Kazuhiro Yuasa, Toyama, JAPAN; Kiyohiko Maeda, Toyama, JAPAN; Kiyohiko Maeda, Toyama, JAPAN;  **CONTINUING DATA **** This application is a 371 of PCTI/PO4/12214 08/25/2004  **FOREIGN APPLICATIONS **JAPAN 2003-301982 08/26/2003  **IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/30/2007  **Foreign Pictify claimed **SUSC 119(e-d) conditions met ** **If Yes   No Verified and **If Yes	10/549,93	.938 (			438	2891		NO. 1592-0169PUS1		
Takashi Ozaki, Toyama, JAPAN; Kazuhiro Yuasa, Toyama, JAPAN; Kiyohiko Maeda, Toyama, JAPAN; Kiyohiko Maeda, Toyama, JAPAN; ***CONTINUING DATA **********************************	RULE									
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FALLS CHURCH, VA 22040-0747 UNITED STATES										
TITLE										
Producing method of semiconductor device and substrate processing apparatus										
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□ 1.16 Fees (Filling)		FFEC: Author	FEES: Authority has been given in Paper  No to charge/credit DEPOSIT ACCOUNT  No for following:				☐ 1.16 Fees (Filing)			
							1.17 Fees (Processing Ext. of time)			
							☐ 1.18 Fees (Issue)			
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